

Notice of References Cited	Application/Control No. 10/669,507	Applicant(s)/Patent Under Reexamination YAMAGUCHI ET AL.	
	Examiner G. Nagesh Rao	Art Unit 1722	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,227,870	10-1980	Kim, Heung T.	425/208
	B	US-6,136,246	10-2000	Rauwendaal et al.	264/211.21
	C	US-5,458,834	10-1995	Faber et al.	264/109
	D	US-4,171,196	10-1979	Maillefer, Charles	425/209
	E	US-4,839,120	06-1989	Baba et al.	264/102
	F	US-2002/0014710	02-2002	Tsuruta et al.	264/40.6
	G	US-5,932,159	08-1999	Rauwendaal, Chris J.	264/211.21
	H	US-5,984,516	11-1999	Inoue et al.	366/85
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.